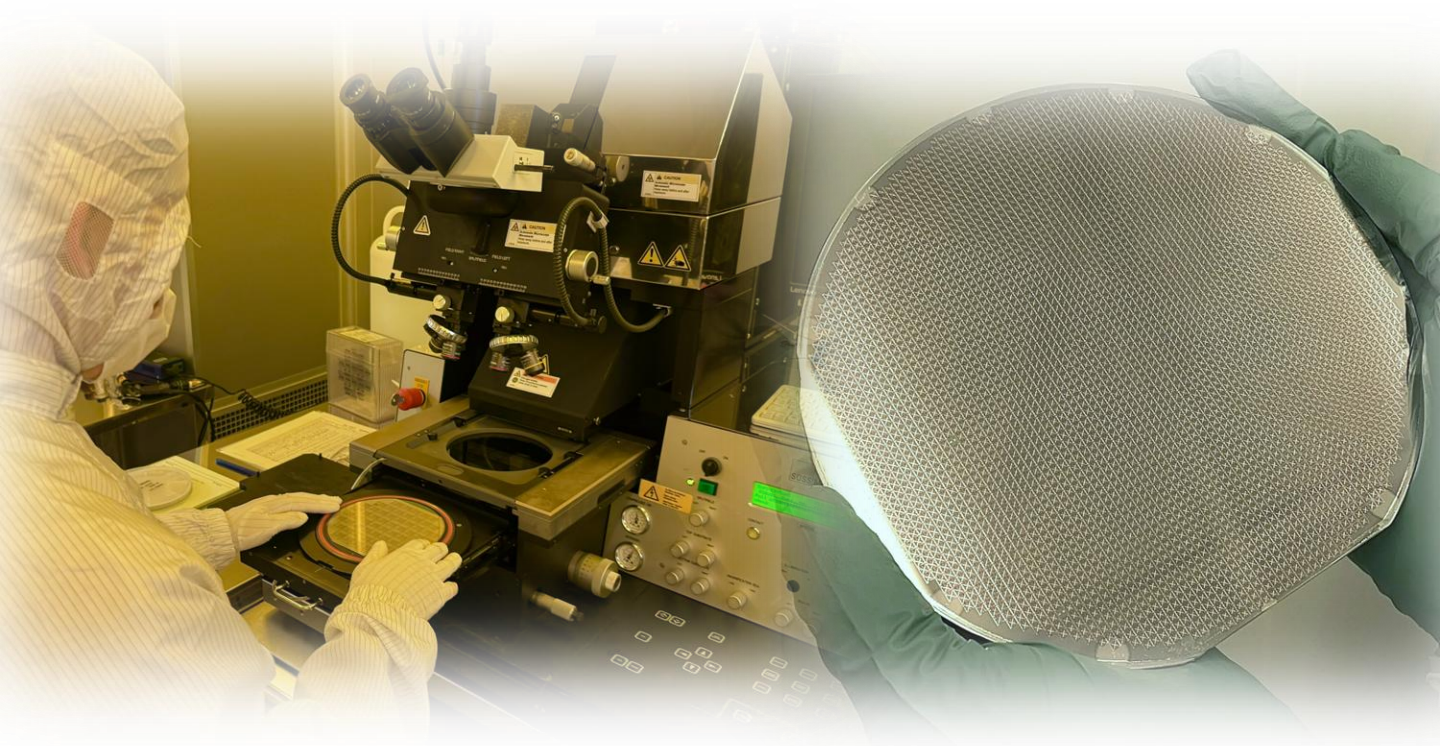


Piezo-MEMS Foundry

Your Dedicated Partner for Piezo-MEMS Innovation



Surface & Bulk Micromachining Process

• Process/Equipment

Process	Equipment	Note
Photolithography	Spin Coater & Track System	Sample ~ 8 inch
	Mask Aligner	Sample ~ 8 inch
	Wet Station & Spin Dryer	
	Plasma Asher & Cleaner	
Chemical Vapor Deposition	PECVD	Poly Silicon, SiO ₂
E-beam Lithography	E-beam Evaporator	4~8 inch/Au, Cu, N, Al, etc.
Dry Etcher	DRIE & ICP Etcher	PZT, Si, Oxide & Metal film each
	Ion Beam Etching System	4 ~ 8 inch
Oxidation	Diffusion Furnace	2 ~ 8 inch
Others	Dicing Saw	
	Anodic Bonder, Bonding Aligner & Wire Bonder	
	Grinding / Polishing Machine	

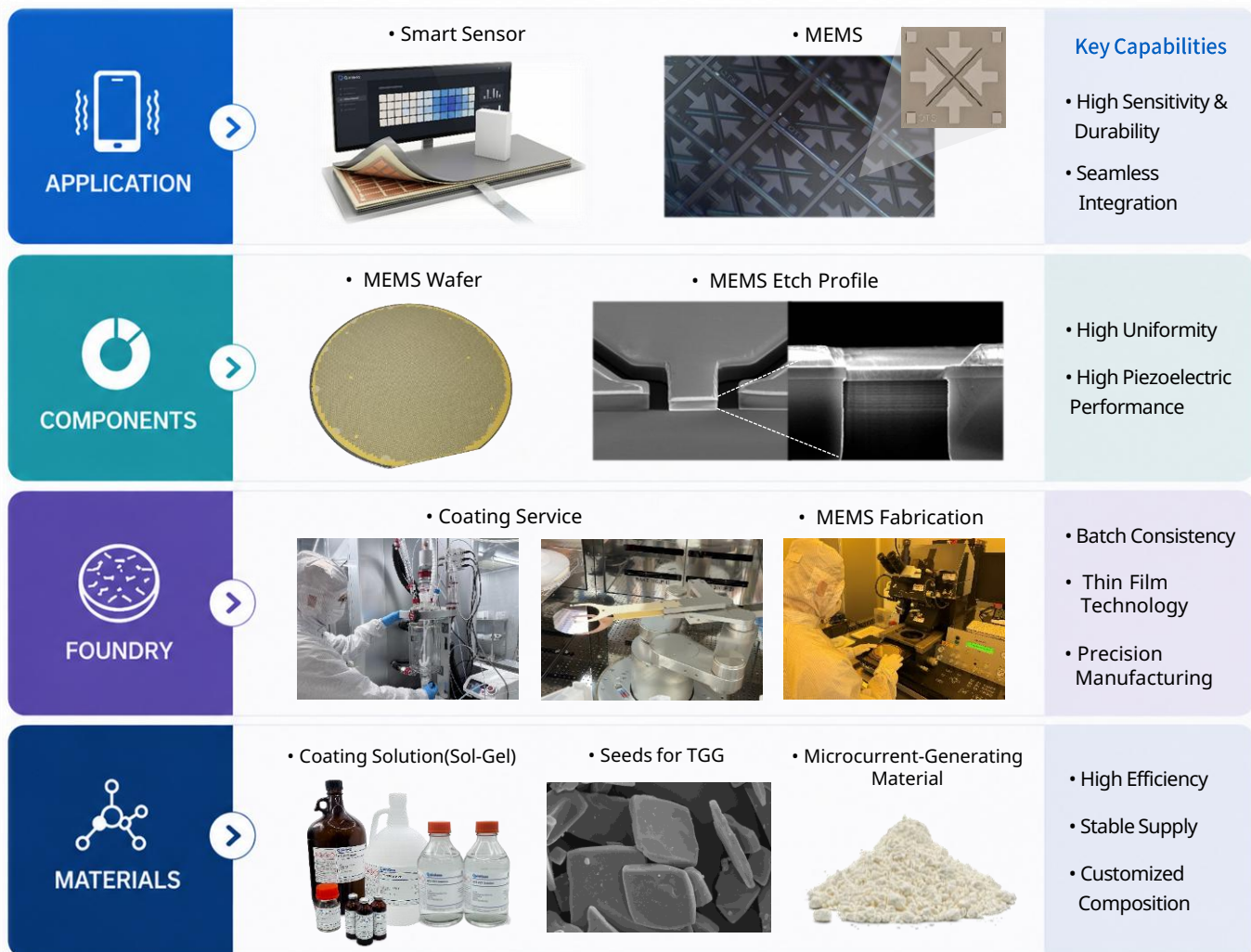


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